

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s):	ZAII, Eitan	Examiner:	FRASER, Stewart A.
Serial No.:	10/564,972	Group Art Unit:	1795
Filed:	August 1, 2006	Confirmation No.:	7182
Title:	METHOD FOR CORRECTING CRITICAL DIMENSION VARIATIONS IN PHOTOMASKS		

AMENDMENT

Mail Stop Amendment

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

Sir:

This Amendment is filed in response to the Office Action dated January 7, 2009 issued by the United States Patent and Trademark Office in connection with the above-identified Application. A response to the January 7, 2009 Office Action was due April 7, 2009. Applicants are concurrently filing a Petition for a One-Month Extension of Time, including the required fee. Therefore, a response is due May 7, 2009. Accordingly, this Amendment is being timely filed.

Kindly amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page **2** of this paper.

Remarks begin on page **5** of this paper.